
21. (New) The device of claim 1, wherein said metal plug contact contacts said field oxide layer.

~~C~~
22. (New) The method of claim 5, wherein said metal plug contact contacts said field oxide layer.

~~D~~
23. (New) The device of claim 9, wherein said metal plug contact contacts said field oxide layer.

~~D~~
24. (New) The method of claim 13, wherein said metal plug contact contacts said field oxide layer.
